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APPLICANT:

Vestal

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MASS SPECTROMETER SYSTEM AND METHOD FOR

MATRIX-ASSISTED LASER DESORPTION

**MEASUREMENTS** 

Commissioner for Patents Washington, D.C. 20231

## CHINE CHINE SUPPLEMENTAL AMENDMENT AND RESPONSE

Sir:

In response to the Office communication mailed from the United States Patent and Trademark Office on March 15, 2002, ("the Communication") Applicant submits this supplemental paper. Per the Examiner's request in a telephone conversation with the undersigned Attorney on March 21, 2002, Applicant submits this supplemental paper in the form of a Supplemental Amendment and Response to the Amendment and Response filed November 19, 2001, responding to the Office action of July 17, 2001, ("the Office action").

Applicant believes that no fee is due with this supplemental paper based on the grant by the Communication of a one month time period for response. However, if Applicant is in error, the Director is hereby authorized to charge any required fee to Deposit Account No. 50-1191.